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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. .... 10/264,615  
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Inventor ..... Luan C. Tran  
Assignee ..... Micron Technology, Inc.  
Priority Group Art Unit ..... 2813  
Priority Examiner ..... Laura M. Schillinger  
Attorney's Docket No. ..... MI22-2331  
Title: Semiconductor Processing Methods of Forming Integrated Circuitry

**PRELIMINARY AMENDMENT**

To: Mail Stop Patent Application  
Commissioner for Patents  
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This Preliminary Amendment accompanies a Request for Divisional Application for the above-titled patent application. Please enter the following amendments prior to examining the above-identified application.

**AMENDMENT**

Underlines indicate insertions and ~~strikeouts~~ indicate deletions.